

Notice of References Cited	Application/Control No. 10/527,683	Applicant(s)/Patent Under Reexamination TAKAHASHI ET AL.	
	Examiner Michelle Estrada	Art Unit 2823	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-6,475,854 B2	11-2002	Narwankar et al.	438/238
*	C	US-6,664,116 B2	12-2003	Li et al.	438/3
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	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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